



#10 AMDT
C
5/10/01
18

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/512,968
Filing Date February 24, 2000
Inventor David R. Hembree
Assignee Micron Technology, Inc.
Group Art Unit 2832
Examiner V. Nguyen
Attorney's Docket No. MI22-1363
Title: Wafer Processing Apparatuses and Electronic Device Workpiece
Processing Apparatuses (As Amended)

RESPONSE TO JANUARY 29, 2001 OFFICE ACTION

To: Assistant Commissioner for Patents
Washington, D.C. 20231

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)
Wells, St. John, Roberts, Gregory & Matkin P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Sir:

Responsive to the Office Action dated January 31, 2001, Applicant
amends and remarks as follows:

03/04/2001 SWINASS1 00000019 09512968

01 FC:103
01 FC:102

90.00 OP
640.00 OP

AMENDMENTS

In the Title

Please replace the title with the following: --WAFER PROCESSING
APPARATUSES AND ELECTRONIC DEVICE WORKPIECE PROCESSING
APPARATUSES--.